



Atty. Docket No. 8043-1004

PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Katsuhisa YUDA

Confirmation No. 6697

Serial No. 09/729,193

GROUP 1763

Filed December 5, 2000

Examiner L. Alejandro Mulero

PLASMA CVD APPARATUS AND PLASMA  
CVD METHOD

AMENDMENT

#5B  
8/27/02  
MW

Commissioner for Patents

Washington, D.C. 20231

Sir:

Responsive to the Official Action of June 6, 2002,  
please amend the above-identified application as follows:

IN THE TITLE:

Change the title throughout, declaration excepted, to  
--PLASMA CVD APPARATUS COMPRISING A PLASMA CONFINING ELECTRODE--.

IN THE ABSTRACT:

A substitute Abstract of the Disclosure is provided on  
an accompanying separate sheet.

In THE SPECIFICATION:

Page 1, between lines 12 and 13, insert the following  
heading:

--BACKGROUND OF THE INVENTION--.

B2

RECEIVED  
AUG 26 2002  
TC 1700